Listing Of Claims

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Claims 1-152 (Canceled)

- 153. (original) A semiconductor component comprising:
- a thinned semiconductor die having a circuit side, a thinned back side and a plurality of peripheral edges;
- a first polymer layer covering the circuit side and the edges; and
 - a second polymer layer covering the back side.
- 154. (original) The semiconductor component of claim 153 further comprising a plurality of die contacts on the die, and a plurality of contact bumps on the die contacts embedded in the first polymer layer.
- 155. (original) The semiconductor component of claim 154 further comprising a plurality of terminal contacts on the contact bumps.
- 156. (original) The semiconductor component of claim 154 wherein the terminal contacts comprise bumps or balls in a grid array, or planar pads configured as an edge connector.
- 157. (original) The semiconductor component of claim 154 wherein the second polymer layer is opaque to radiation at a selected wavelength.
- 158. (original) The semiconductor component of claim 154 wherein the second polymer layer comprises a wafer level underfill tape.
- 159. (original) The semiconductor component of claim 154 wherein the second polymer layer comprises parylene.

- 160. (original) The semiconductor component of claim 154 wherein the second polymer layer comprises a photoresist.
- 161. (original) The semiconductor component of claim
 154 wherein the second polymer layer comprises a tape.
- 162. (original) The semiconductor component of claim 154 wherein the second polymer layer comprises a stereographic imageable resist.
- 163. (original) The method of claim 154 further comprising etching the substrate following the thinning step such that the substrate is recessed with respect to the portions of the polymer filled trenches.
- 164. (original) The method of claim 163 wherein a thickness of the substrate following the etching step is about 10 μm to 250 μm .
- 165. (original) The semiconductor component of claim 154 further comprising a polymer tape attached to the thinned back side which is opaque to radiation at a selected wavelength, and a laser marking on the polymer tape.
- 166. (original) The semiconductor component of claim 154 further comprising a conductive via in the thinned substrate.
- 167. (original) The semiconductor component of claim 166 wherein the conductive via comprises a conductive member exposed with respect to the substrate to provide a pin terminal contact.

- 168. (original) The semiconductor component of claim 166 wherein the conductive via comprises a conductive member, a conductor on the back side and a terminal contact on the back side in electrical communication with the conductivity region.
- 169. (original) The semiconductor component of claim 166 wherein the conductive via comprises a reverse bias junction.
 - 170. (original) A semiconductor component comprising:
- a thinned semiconductor die having a circuit side, a back side, four peripheral edges, and a plurality of die contacts;
 - a plurality of contact bumps on the die contacts;
- a first polymer layer covering the circuit side, the contact bumps and the peripheral edges;
 - a second polymer layer covering the back side; and
 - a plurality of terminal contacts on the contact bumps.
- 171. (original) The semiconductor component of claim 170 wherein the contact bumps and the first polymer layer are planarized to a same surface.
- 172. (original) The semiconductor component of claim 170 wherein the contact bumps comprise metal bumps.
- 173. (original) The semiconductor component of claim 170 wherein the terminal contacts comprise conductive bumps or balls.
- 174. (original) The semiconductor component of claim 170 wherein the first polymer layer has a planarized first surface.

- 175. (original) The semiconductor component of claim 170 wherein the second polymer layer has a planarized second surface.
- 176. (original) The semiconductor component of claim 170 further comprising a plurality of conductive vias in electrical communication with the die contacts and with the terminal contacts.
- 177. (original) The semiconductor component of claim 176 further comprising a plurality of second die contacts on the second polymer layer in electrical communication with the conductive vias.
- 178. (original) The semiconductor component of claim 170 wherein the second polymer layer comprises a photopolymer.
- 179. (original) The semiconductor component of claim 170 wherein the second polymer layer comprises a wafer level underfill.
 - 180. (original) A semiconductor component comprising:
- a thinned semiconductor die having a circuit side, a back side and four peripheral edges;
- a circuit side polymer layer covering the circuit side:
- a plurality of edge polymer layers covering the four peripheral edges, the edge polymer layers and the circuit side polymer layer comprising a continuous layer of material, the edge polymer layers comprising portions of polymer filled trenches; and
 - a back side polymer layer covering the back side.
- 181. (original) The semiconductor component of claim 180 further comprising a plurality of die contacts on the

die, and a plurality of contact bumps on the die contacts embedded in the circuit side polymer layer.

- 182. (original) The semiconductor component of claim 180 further comprising a plurality of die contacts on the die, and a plurality of planarized contact bumps on the die contacts embedded in the circuit side polymer layer and planarized to a surface thereof.
- 183. (original) The semiconductor component of claim 180 further comprising a plurality of terminal contacts on the contact bumps.
- 184. (original) The semiconductor component of claim 180 further comprising a plurality of conductive vias through the die
- 185. (original) The semiconductor component of claim 180 further comprising a plurality of conductive vias through the die including exposed portions configured as pins.
- 186. (original) The semiconductor component of claim 180 further comprising a plurality of conductive vias through the die including tip portions, a plurality of conductors on the back side in electrical communication with the conductors, and a plurality of terminal contacts on the back side in electrical communication with the tip portions.
- 187. (original) The semiconductor component of claim 180 wherein the back side polymer layer is opaque to radiation at a selected wave length.

- 188. (original) The semiconductor component of claim 180 wherein the back side polymer layer comprises a wafer level underfill.
 - 189. (original) A semiconductor component comprising:
- a semiconductor wafer having a circuit side and a back side, the wafer comprising a thinned substrate and a plurality of semiconductor dice on the thinned substrate separated by streets;
- a plurality of polymer filled trenches in the thinned substrate in the streets;
- a planarized circuit side polymer layer on the circuit side; and
 - a planarized back side polymer layer in the back side.
- 190. (original) The semiconductor component of claim 189 further comprising a plurality of die contacts on the dice, and a plurality of contact bumps on the die contacts embedded in the planarized circuit side polymer layer.
- 191. (original) The semiconductor component of claim 190 further comprising a plurality of terminal contacts on the contact bumps.
- 192. (original) The semiconductor component of claim 191 further comprising a plurality of conductive vias in the substrate in electrical communication with the die contacts and with the terminal contacts.
- 193. (original) The semiconductor component of claim 191 wherein the terminal contacts comprise bumps or balls in a grid array.
- 194. (original) The semiconductor component of claim 191 wherein the terminal contacts are configured as an edge connector.

- 195. (original) The semiconductor component of claim 191 further comprising a plurality of second terminal contacts on planarized back side polymer layer in electrical communication with the conductive vias.
 - 196. (original) A semiconductor component comprising:
- a thinned semiconductor die having a circuit side, a back side, four peripheral edges, and a plurality of die contacts on the circuit side;
- a first polymer layer covering the circuit side and the peripheral edges;
- a plurality of conductive vias in the die in electrical communication with the die contacts;
 - a second polymer layer covering the back side;
- and a plurality of terminal contacts in electrical communication with the conductive vias and the die contacts.
- 197. (original) The semiconductor component of claim 196 wherein the terminal contacts are on the circuit side.
- 198. (original) The semiconductor component of claim 196 wherein the terminal contacts are on the back side.
- 199. (original) The semiconductor component of claim 196 wherein the terminal contacts are on both the circuit side and the back side.
- 200. (original) The semiconductor component of claim 196 wherein the terminal contacts are offset from the conductive vias.
- 201. (original) The semiconductor component of claim 196 wherein each conductive via comprise a reverse bias junction.

- 202. (original) The semiconductor component of claim 196 wherein the terminal contacts are configured as an edge connector.
- 203. (original) The semiconductor component of claim 196 wherein the terminal contacts are bonded to contact bumps on the die contacts.
- 204. (original) The semiconductor component of claim 196 wherein the terminal contacts are bonded to planarized contact bumps on the die contacts planarized to a surface of the first polymer layer.
- 205. (original) The semiconductor component of claim 196 wherein the conductive vias comprise openings in the die, insulating layers on the openings, and a conductive material in the openings.
- 206. (original) The semiconductor component of claim 196 wherein the conductive vias comprise portions of the die implanted with a dopant.
- 207. (original) The semiconductor component of claim 196 wherein the terminal contacts comprise portions of the conductive vias configured as pin contacts.
- 208. (original) The semiconductor component of claim 196 wherein the terminal contacts comprise balls or bumps in an area array.
 - 209. (original) A semiconductor component comprising:
- a thinned semiconductor die having a circuit side and a thinned back side;
 - a polymer layer covering the circuit side; and
 - a heat sink attached to the thinned back side.

- 210. (original) The semiconductor component of claim 209 further comprising a thermally conductive adhesive attaching the heat sink to the thinned back side.
- 211. (original) The semiconductor component of claim 209 wherein the die comprise a plurality of edges and the polymer layer covers the edges.
- 212. (original) The semiconductor component of claim 209 wherein the die comprises a plurality of die contacts on the circuit side, contact bumps on the die contact and terminal contacts on the contact bumps.
- 213. (original) The semiconductor component of claim 209 wherein the die comprises a plurality of die contacts on the circuit side, planarized contact bumps on the die contact and terminal contacts on the planarized contact bumps.
 - 214. (original) A semiconductor component comprising:
- a thinned semiconductor die having a circuit side and a thinned back side;
 - a polymer layer covering the circuit side;
 - a polymer tape attached to the thinned back side; and
 - a marking in the polymer tape.
- 215. (original) The semiconductor component of claim 214 wherein the marking comprises a laser marking and the polymer tape is opaque to radiation of a selected wave length.
- 216. (original) The semiconductor component of claim 214 wherein the die comprise a plurality of edges and the polymer layer covers the edges.

2 1

- 217. (original) The semiconductor component of claim 214 wherein the die comprises a plurality of die contacts on the circuit side, contact bumps on the die contacts, and terminal contacts on the contact bumps.
- 218. (original) The semiconductor component of claim 214 wherein the die comprises a plurality of die contacts on the circuit side, planarized contact bumps on the die contacts, and terminal contacts on the planarized contact bumps.
- 219. (original) The semiconductor component of claim 214 wherein the polymer tape comprises a wafer level underfill.
 - 220. (original) A semiconductor component comprising:
- a semiconductor die having a circuit side, a back side, four peripheral edges, and an array of die contacts on the circuit side;
 - a polymer layer covering the circuit side;
- a protective coating covering the edges and the back side; and
 - a plurality of terminal contacts on the die contacts.
- 221. (original) The semiconductor component of claim 220 further comprising a plurality of contact bumps on the die contacts.
- 222. (original) The semiconductor component of claim 220 further comprising a plurality of planarized contact bumps on the die contacts planarized to a surface of the polymer layer.
- 223. (original) The semiconductor component of claim 220 wherein the protective coating comprises parylene.

- 224. (original) The semiconductor component of claim 220 wherein the terminal contacts comprise bumps or balls in a grid array.
- 225. (original) The semiconductor component of claim 220 wherein the terminal contacts are configured as an edge connector.
- 226. (original) The semiconductor component of claim 220 wherein the peripheral edges comprise etched surfaces.
 - 227. (original) A semiconductor component comprising:
- a thinned semiconductor die having a circuit side, a back side, four peripheral edges, and a plurality of die contacts:
- a first polymer layer covering the circuit side comprising a first polymer material; and
- a plurality of second polymer layers covering the peripheral edges comprising a second polymer material.
- 228. (original) The semiconductor component of claim 227 further comprising a plurality of contact bumps on the die contacts embedded in the first polymer layers and a plurality of terminal contacts on the contact bumps.
- 229. (original) The semiconductor component of claim 228 wherein the contact bumps and the first polymer layer are planarized to a same surface.
- 230. (original) The semiconductor component of claim 228 wherein the contact bumps comprise conductive bumps or balls.
- 231. (original) The semiconductor component of claim 228 wherein the second polymer layers comprise a photoimageable resist.

- 232. (original) The semiconductor component of claim 228 wherein the second polymer layer comprise a stereo lithographic imageable material.
 - 233. (original) A semiconductor component comprising:
- a thinned semiconductor die having a circuit side, a back side, and a plurality of die contacts on the circuit side:
- a plurality of conductive vias in the die in electrical communication with the die contacts;
- and a plurality of terminal contacts in electrical communication with the conductive vias and the die contacts comprising pin contacts.
- 234. (original) The semiconductor component of claim 233 wherein the pin contacts comprise conductive portions of the conductive vias.
- 235. (original) The semiconductor component of claim 233 wherein the pin contacts comprise a pin grid array.
- 236. (original) The semiconductor component of claim 233 wherein each conductive via comprises a reverse junction bias.
- 237. (original) The semiconductor component of claim 233 further comprising a second polymer layer covering the back side.
- 238. (original) The semiconductor component of claim 233 wherein the thinned die has a thickness of from about 10 μm to 250 μm .

- 239. (original) The semiconductor component of claim 233 further comprising a first polymer layer covering at least the circuit side.
- 240. (original) The semiconductor component of claim 239 wherein the first polymer layer covers edges of the die.
- 241. (original) The semiconductor component of claim 239 further comprising a second polymer layer covering the back side.
 - 242. (original) A semiconductor component comprising:
- a thinned semiconductor die having a circuit side, a back side, and a plurality of die contacts on the circuit side;
- a plurality of conductive vias in the die in electrical communication with the die contacts;
- and a plurality of terminal contacts in electrical communication with the conductive vias and the die contacts comprising tip portions projecting from the thinned semiconductor die;
- a plurality of conductors in electrical communication with the tip portions; and
- a plurality of terminal contacts in electrical communication with the conductors.
- 243. (original) The semiconductor component of claim 242 wherein the tip portions comprise a conductive material.
- 244. (original) The semiconductor component of claim 242 wherein the terminal contacts comprise ball or bumps in a grid array.

- 245. (original) The semiconductor component of claim 242 wherein the conductive vias comprise reverse bias junctions.
- 246. (original) The semiconductor component of claim 242 further comprising a first polymer layer covering at least the circuit side.
- 247. (original) The semiconductor component of claim 246 wherein the first polymer layer covers edges of the die.
- 248. (original) The semiconductor component of claim 246 further comprising a second polymer layer covering the back side.
 - 249. (original) A system comprising:
 - a substrate; and
 - a component on the substrate comprising:
- a thinned semiconductor die having a circuit side, a back side and a plurality of peripheral edges;
- a first polymer layer covering the circuit side and the edges;
- a second polymer layer covering the back side; and
- a plurality of terminal contacts on the first polymer layer in electrical communication with the die and bonded to the substrate.
- 250. (original) The system of claim 249 further comprising a plastic body encapsulating the substrate and the component.
- 251. (original) The system of claim 249 further comprising a plurality of planarized contact bumps on the die embedded in the first polymer layer.

- 41. 4
- 252. (original) The system of claim 249 wherein the substrate comprises a plurality of terminal leads in electrical communication with the terminal contacts.
- 253. (original) The system of claim 249 wherein the substrate comprises an edge connector in electrical communication with the terminal contacts.
- 254. (original) The system of claim 249 wherein the system comprises a system in a package.
- 255. (original) The system of claim 249 wherein the substrate comprises a module substrate and the system comprises a multi chip module.
 - 256. (original) A system in a package comprising:
 - a substrate comprising a plurality of terminal leads;
- a component mounted to the substrate, the component comprising:
- a thinned semiconductor die having a circuit side, a back side, four peripheral edges, and an area array of die contacts;
 - a plurality of contact bumps on the die contacts;
- a first polymer layer covering the circuit side, the contact bumps and the peripheral edges;
- a second polymer layer covering the back side; and
- a plurality of terminal contacts on the contact bumps in electrical communication with the terminal leads; and
- a plastic body encapsulating the substrate and the component.

- 257. (original) The system of claim 256 wherein the terminal contacts comprise bumps or balls and the component is flip chip mounted to the substrate.
- 258. (original) The system of claim 256 wherein the terminal contacts comprise an edge connector and the component is edge connector mounted to the substrate.
- 259. (original) A stacked semiconductor system comprising:
 - a first semiconductor component comprising:
- a thinned semiconductor die having a circuit side, a back side, four peripheral edges, and an array of die contacts on the circuit side;
 - a plurality of contact bumps on the die contacts;
- a first polymer layer covering the circuit side, the peripheral edges, and portions of the contact bumps;
- a plurality of conductive vias in the die in electrical communication with the contact bumps;
- a second polymer layer covering the back side; and a plurality of terminal contacts on the back side in electrical communication with the conductive vias; and
- a second semiconductor component substantially identical to the first semiconductor component comprising a plurality of second terminal contacts bonded to the contact bumps.
- 260. (original) The stacked semiconductor system of claim 259 wherein the conductive vias comprise openings in the die, insulating layers on the openings, and a conductive material in the openings.
- 261. (original) The stacked semiconductor system of claim 259 wherein the terminal contacts comprise balls or bumps in a grid array.